Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination
10/749,711	JACOB, KURIAN
Examiner	Art Unit
Khai M. Nauven	2617

	SEARCHED			
Class	Subclass	Date	Examiner	
455	456.1 456.3 456.4 422.1 457	5/9/2006	KN	
455	435.3	5/9/2006	KN	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
East (see attached)	5/9/2006	КИ	